

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hisao Sato et al.

Application No.: 10/516,703

Confirmation No.: 6746

Filed: December 2, 2004

Art Unit: 2826

For: GALLIUM NITRIDE COMPOUND
SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD

Examiner: T. N. Tran

REPLY UNDER 37 CFR §1.116

MS: AFTER FINAL
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated September 12, 2007, please reconsider this application in view of the following.